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I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING TRANSMITTED BY FACSIMILE TO THE U.S. PATENT AND TRADEMARK OFFICE AT FAX NUMBER 571-273-8300 ON THE DATE INDICATED BELOW.

By (Printed name): Amy Barger Date: May 26, 2006Signature: Amy BargerMail Stop RCE**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**In Re Patent Application of:
Ravikumar Ramachandran et al.

Conf. No.: 4256

Group Art Unit: 2822

Appln. No.: 10/710,257

Examiner: Khanh B. Duong

Filing Date: June 29, 2004

Attorney Docket No.: FIS920040102US1

Title: METHOD OF FORMING SIDEWELL SPACER USING PLASMA ENHANCED
CVD**AMENDMENT TO ACCOMPANY REQUEST FOR CONTINUED EXAMINATION
UNDER C.F.R. 1.114**

The following Amendment is submitted with an accompanying Request for Continued Examination in response to the final Office Action dated March 29, 2006 in the above-identified patent application. This amendment is being filed within the three-month statutory period set for a response. Please amend the above-identified U.S. patent application, without prejudice, as follows.

Amendments to and Listing of the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.